

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANTS PTO FORM 1449</b>	Atty. Docket No. 10191/3616	Serial No. 10/528181 To Be Assigned
	Applicant(s) KRUMMEL et al.	
	Filing Date Herewith	Group To Be Assigned

## U. S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
/MT/	5,721,430*	Feb. 24, 1998	Jacob Y. WONG			

\* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
						YES	NO
/MT/	198 35 769*	Feb. 17, 2000	Germany				

\* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

## OTHER DOCUMENTS

EXAMINER'S INITIALS	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.	
/MT/	Portnoff et al., <i>Enhancement of MOS Gas Sensor Selectivity By 'On-Chip' Catalytic Filtering</i> , Sensors and Actuators, Lausanne, Switzerland, Aug. 1, 1991, Vol. B05, No. 1/4, pgs. 231-5.*	

\* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

EXAMINER /Marcus Taningco/	DATE CONSIDERED 10/26/2007
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	